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## APPLICANTS

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*None MG*  
 \*\* CONTINUING DATA \*\*\*\*\*

*OK MC*  
 \*\* FOREIGN APPLICATIONS \*\*\*\*\*  
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Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no  <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 9	TOTAL CLAIMS 12	INDEPENDENT CLAIMS +2
Verified and Acknowledged Examiner's Signature <i>Maria Galvao MG</i>	Initials				

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## TITLE

Method of forming polysilicon thin film transistor

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